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|--|--|--|--|--|--|---|--|
| <b>INFORMATION DISCLOSURE CITATION</b><br><i>(Use several sheets if necessary)</i> |  |  |  | Docket Number (Optional)<br><b>H 2182</b>  |  | Application Number<br><b>10/047,556</b> |  |
|  |  |  |  | Applicant(s)<br><b>Martin Klein et al.</b> |  |   |  |
|  |  |  |  | Filing Date<br><b>October 23, 2001</b>     |  | Group Art Unit<br><b>2884</b>           |  |

  

| U.S. PATENT DOCUMENTS |  |                 |      |      |       |          |                               |
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| U.S. PATENT APPLICATION PUBLICATIONS |     |                 |      |      |       |          |                               |
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| FOREIGN PATENT DOCUMENTS |     |                 |      |         |       |          |             |    |
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|                          | REF | DOCUMENT NUMBER | DATE | COUNTRY | CLASS | SUBCLASS | Translation |    |
|                          |     |                 |      |         |       |          | YES         | NO |
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| OTHER DOCUMENTS |  |   | (Including Author, Title, Date, Pertinent Pages, Etc.) |
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| SL              |  | Advances in Gas Avalanche Photomultipliers - A. Breskin et al., Dept. of Particle Physics, The Weizmann Institute of Science 76100, Rehovot, Israel - Presented at Beaune99, The Second International Conference on New Developments in Photodetection, Beaune, France, June 21-25, 1999. |  |
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| EXAMINER<br><b>/Shun Lee/</b> | DATE CONSIDERED <b>7/17/2006</b> |
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.